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Serial No. 09/834,950

In the matter of the Application of: Yoshihiko YANO

For: FLUORESCENT THIN FILM, ITS FABRICATION PROCESS, AND EL
PANEL

Due Date: 04/17/03 & 04/27/03

The following has been received in the U.S. Patent Office on the date stamped hereon:

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- Cited References (2)
- Statement of Relevancy
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